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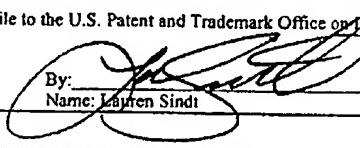
DEC 15 2006

S/N 10/521908

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	TSUKADA	Examiner:	HOANG, Tu Ba
Serial No.:	10/521908	Group Art Unit:	2832
Filed:	January 20, 2005	Docket No.:	10921.0269USWO
Title:	CHIP RESISTOR AND MANUFACTURING METHOD THEREFOR		

CERTIFICATE UNDER 37 CFR 1.6(d):
 I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on December 15, 2006.


 By: _____
 Name: Lauren Stindt
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Dear Sir:

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If there are any questions regarding this matter, please call the undersigned at 612.455.3800.

Respectfully submitted,

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